

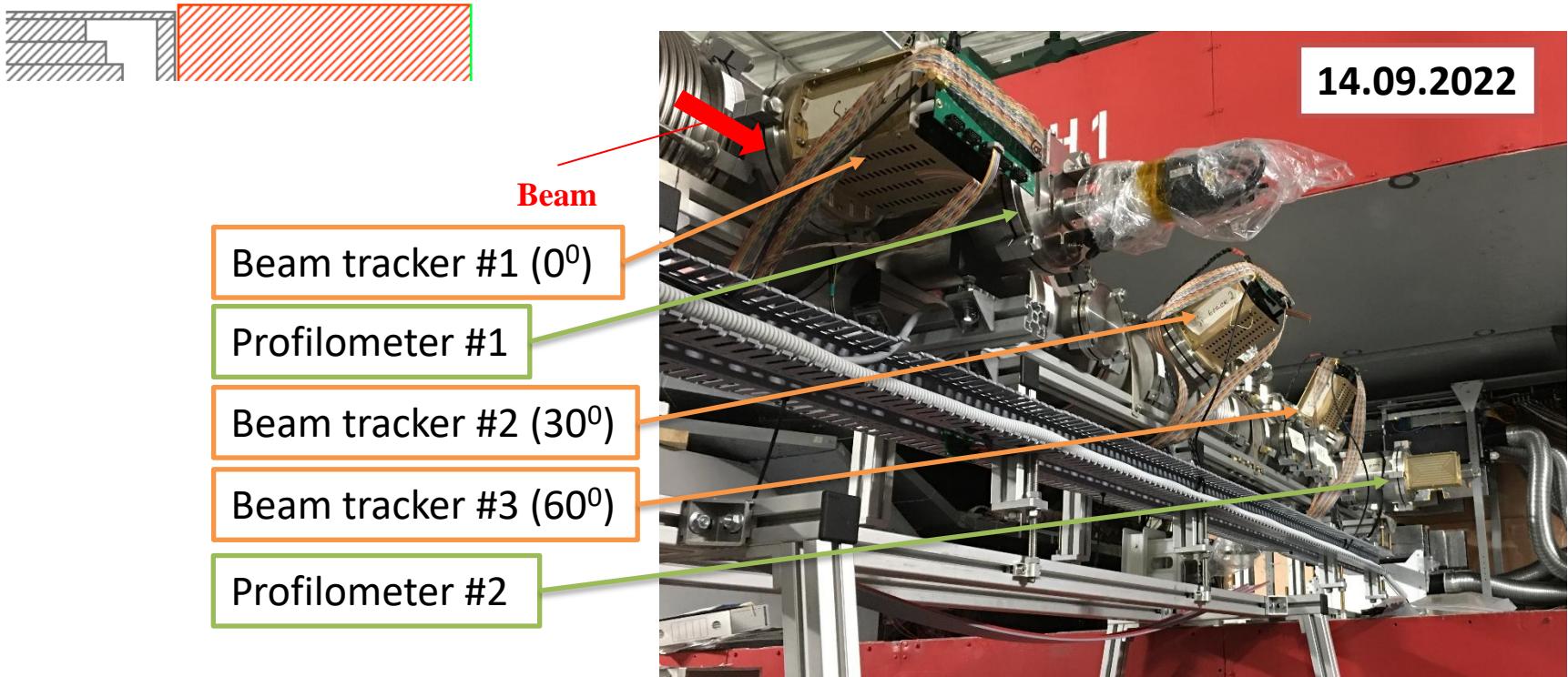
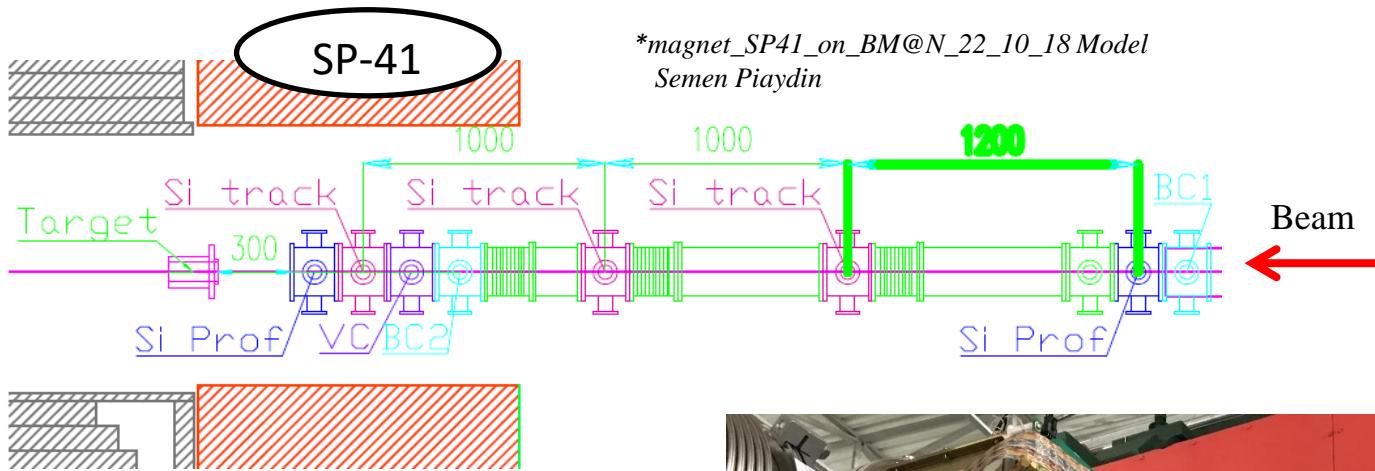


# Forward Silicon Tracker and beam detectors for $Xe$ run - 2022

N. Zamiatin behalf on Si – detectors team

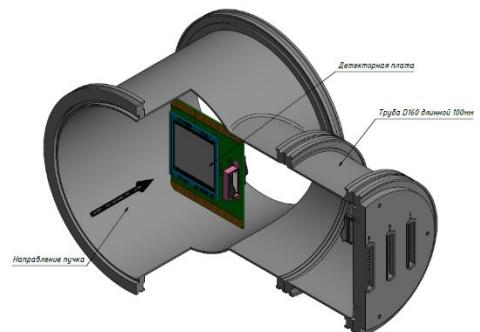
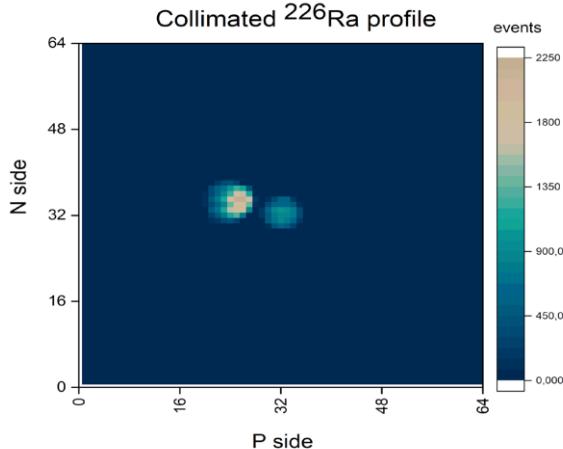
9th Collaboration Meeting of the BM@N Experiment at the NICA Facility,  
14 September 2022

# Position of beam Si detectors before a target

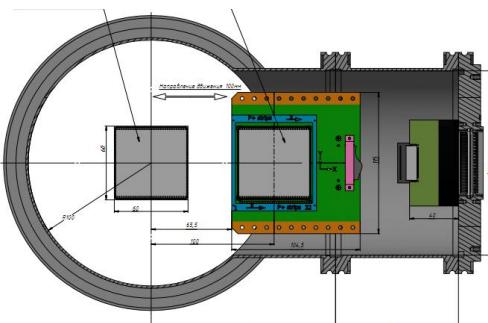


# Beam profilometer

is necessary for beam tuning (alignment of the center beam with the center of the target)



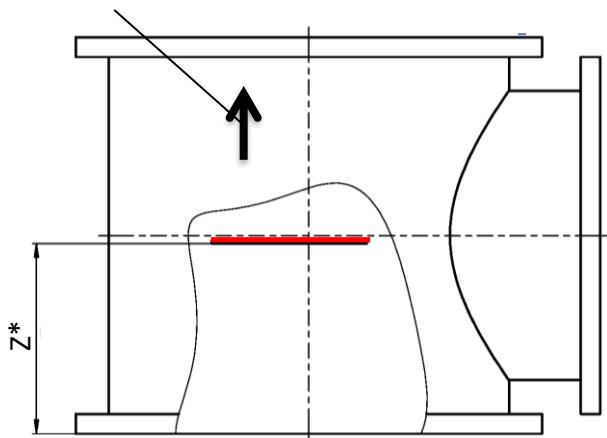
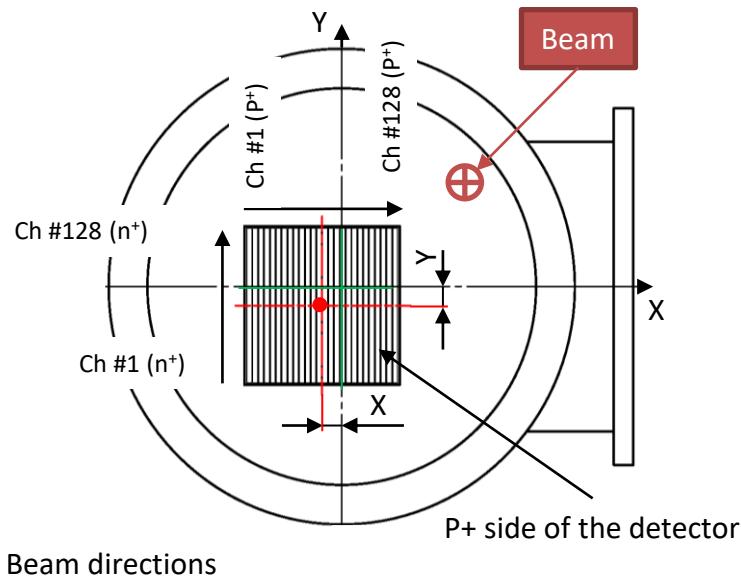
working position



parking position

- **detector:** DSSD, ( $32\text{p}^+ \times 32\text{n}^+$ ), strips pitch = 1.8 mm, thickness (Si) -175  $\mu\text{m}$ , active area ( $60 \times 60$ )  $\text{mm}^2$ ;
- **mechanical design:** the plane of the profilometer is automatically removed from the beam zone to the parking position;
- **FEE:** for light ( ${}_6\text{C} \div {}_{18}\text{Ar}$ ) ions based on **VA163 + TA32cg2 (32 ch, dynamic range (DR): -750fC ± +750fC)** desing in progress;
- **current status:**
  - two vacuum stations with flanges and cable connectors are ready, Silicon Detectors assembled on PCBs and tested with alpha-source (5.5 MeV), autonomus (**ADC+DAQ**) subsystem ready;
  - for heavy (Kr  $\div$  Au) ions will be developed another version of the FEE with DR =  $\pm 20$  pC.

# Position of double-coordinate Si-detectors relative to the axis of the ion guide



\*Distance between the flange surface and the detector surface.  
Detector rotation in the coordinate plane no more than 0.5°

**Beam tracker detector center coordinates relative to the ion guide axis (mm)**

#	X	Y	Z*
#1	0.0	0.9	94.7
#2	2.7	-0.3	96.9
#3 (Al)	0.4	0.1	94.9

Strip pitch in the detector: 0.45 mm

Number of strips: 128x128

Thickness: 175 µm

Size: 63 x 63 mm<sup>2</sup>

**Beam profilometer detector center coordinates relative to the ion guide axis (mm)**

#	X	Y	Z*
#1 (electric)	-1.3±0.1	0.7±0.1	99.7
#2 (pneumatic)	-2.7±0.5	1.4±0.2	100.7

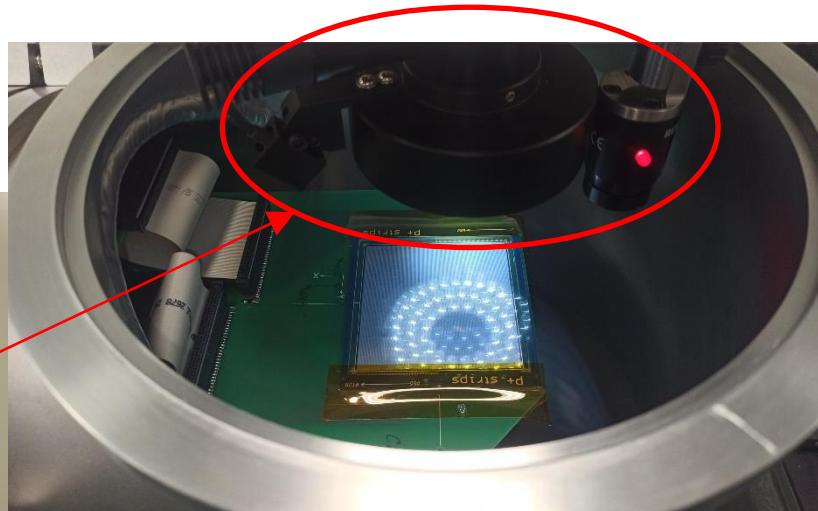
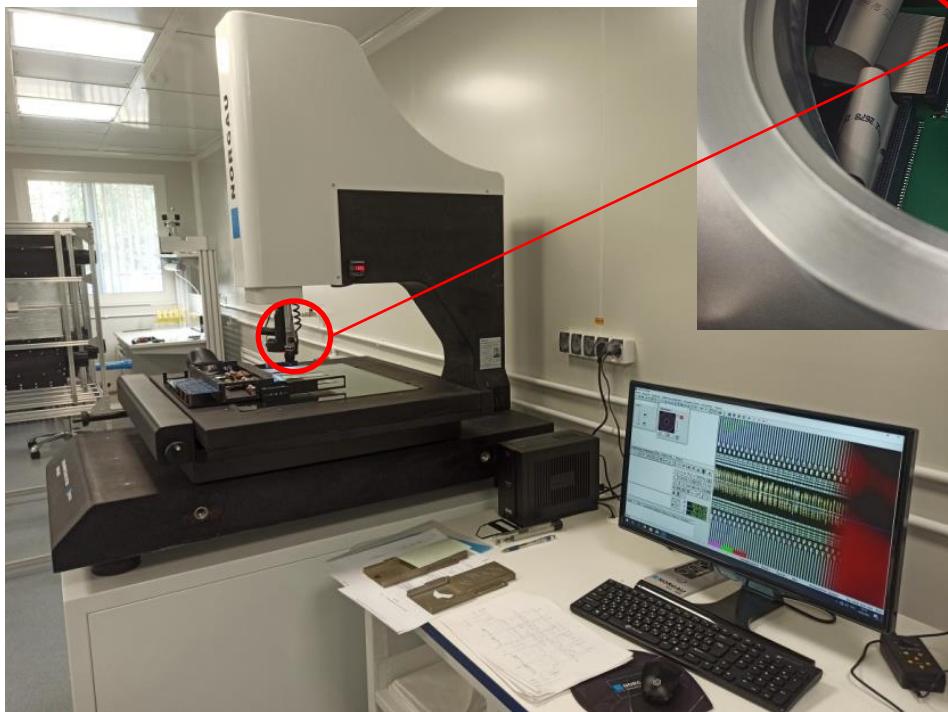
Strip pitch in the detector: 1.87 mm

Number of strips : 32x32

Thickness: 175 µm

Size: 60 x 60 mm<sup>2</sup>

# Measurement of the position of Si-detectors relative to the axis of the beam pipe on a video-measuring microscope "NORGAU" NVM II-5040D.



## «NORGAU» NVM II-5040D

Range of movement along the axes X and Y (mm)	500 x 400
Axis travel range Z (mm)	250
Permissible absolute error of linear measurements along the axes X and Y ( $\mu\text{m}$ )*	$\pm(2.5+L/200)$
Permissible absolute error of linear measurements along the axis Z ( $\mu\text{m}$ )*	$\pm(2.5+L/100)$

\* L – measured length in mm

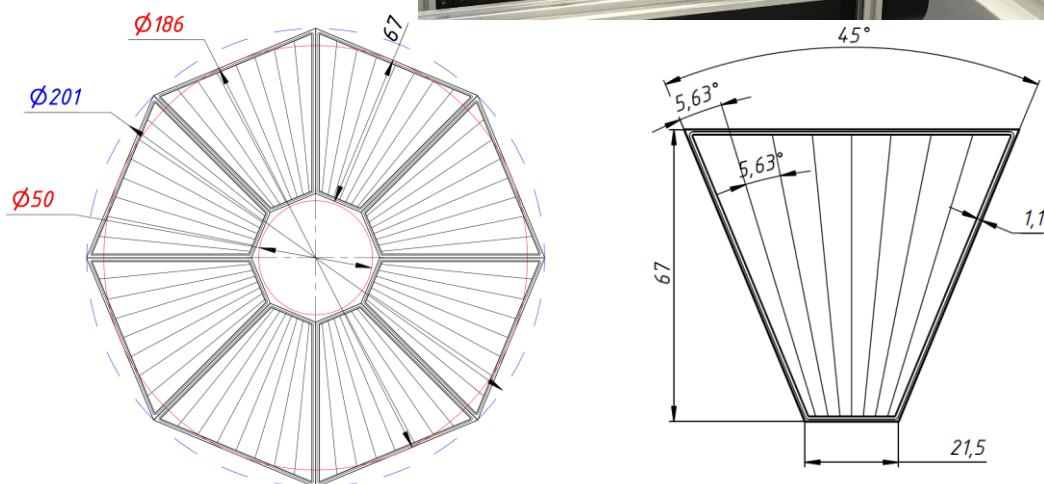
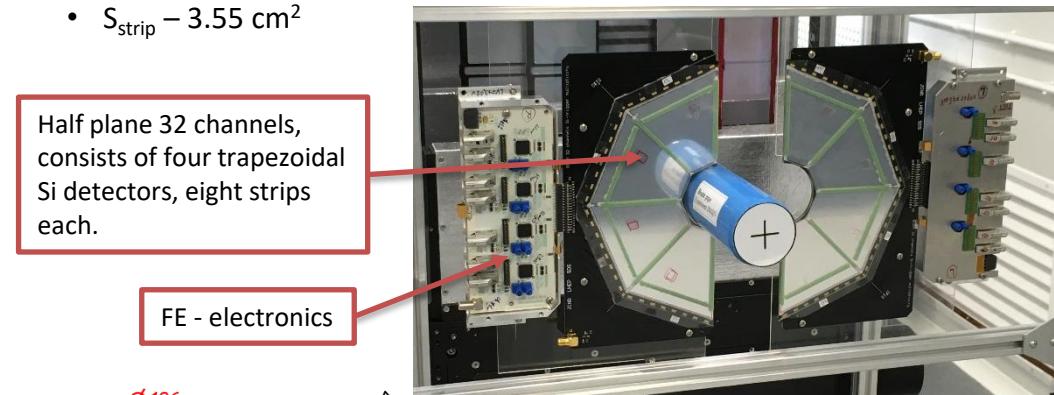
# Si-trigger multiplicity (64ch)

## Si trigger development v.2022

The detecting plane of the silicon trigger is assembled from 8 trapezoidal one-sided detectors:

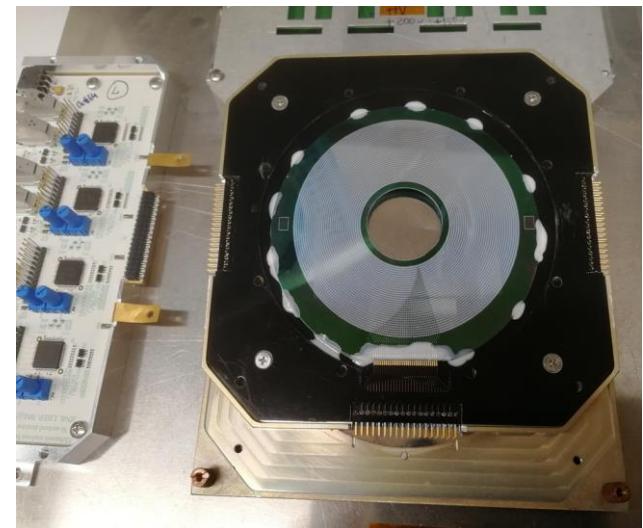
- Total 64 radial strips with 5.63° angle
- Diameter of inner hole for ion guide Ø50 mm (dead zone Ø55 mm)
- External diameter of the sensitive zone 186mm
- Max diameter 201mm
- Detector thickness 500  $\mu\text{m}$
- $S_{\text{strip}} = 3.55 \text{ cm}^2$

Half plane 32 channels,  
consists of four trapezoidal  
Si detectors, eight strips  
each.



## Si trigger development v.2018

- Double sided detector: 64 strips  $\times$  32 rings
- Diameter of inner hole for beam Ø28 mm (dead zone Ø32 mm)
- External diameter of the sensitive zone 86mm
- Detector thickness 520  $\mu\text{m}$
- Detector electronics 64 channels
- The sensitive area of the entrance window is covered with Al-foil, 50  $\mu\text{m}$  thick
- $S_{\text{strip}} = 0.73 \text{ cm}^2$

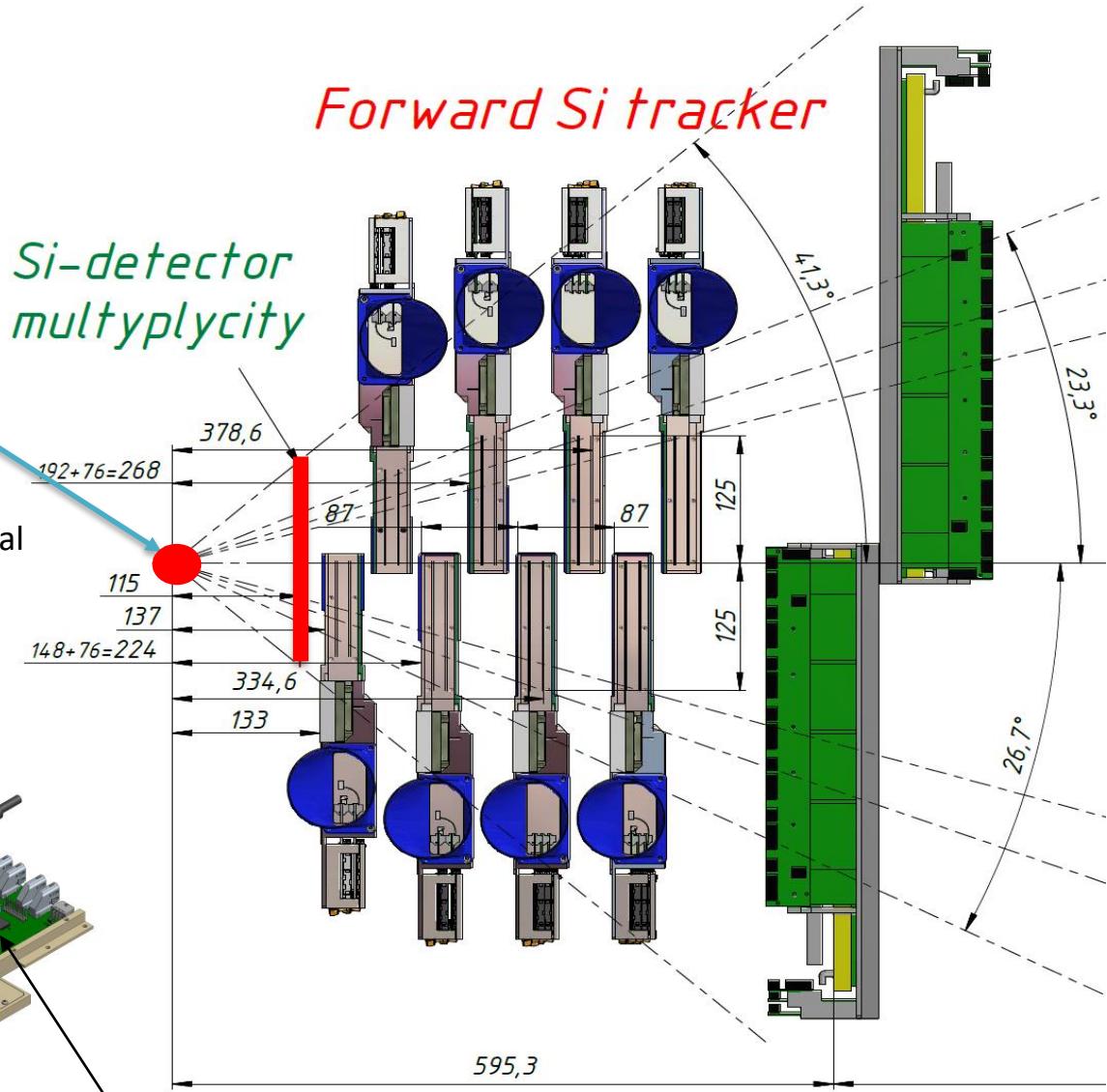
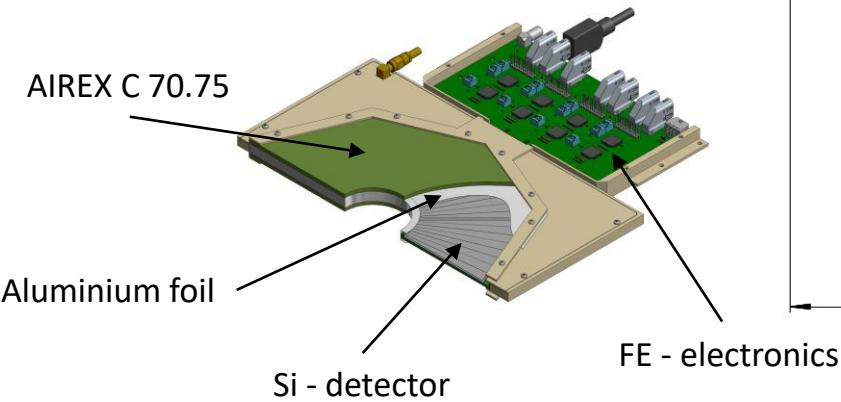


# Aperture of the Si-trigger multiplicity and Si-FW tracker (Y - cross section)

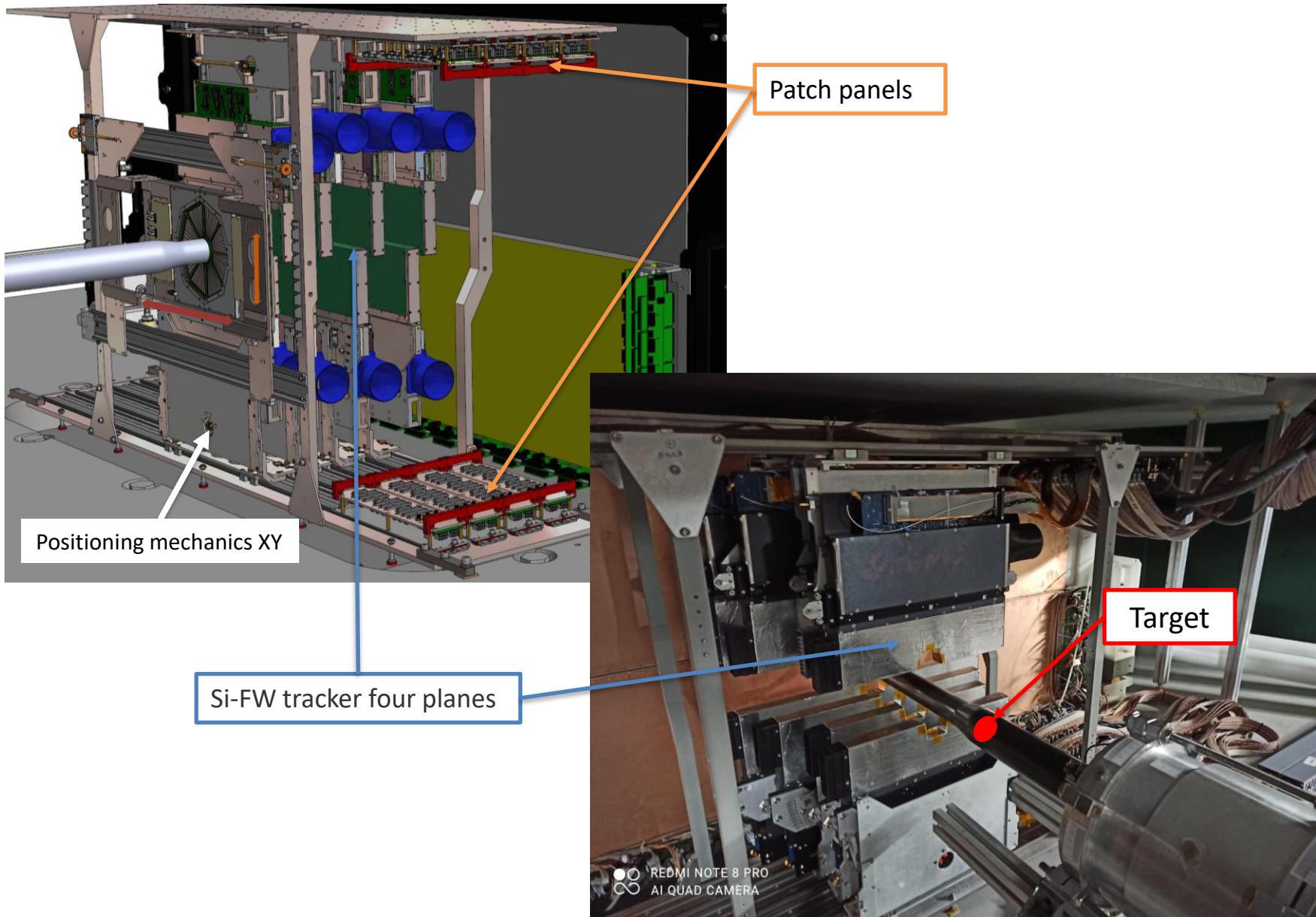
Si trigger is located at a distance of **115 mm** from the target. The light-shielding housing Si of the trigger and the ion guide are not shown.

Target

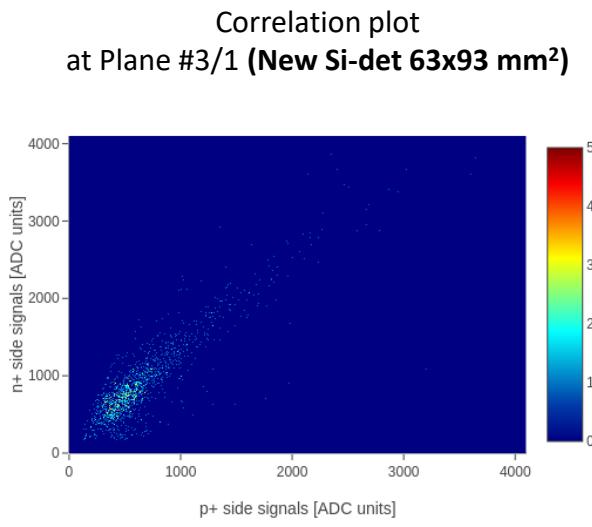
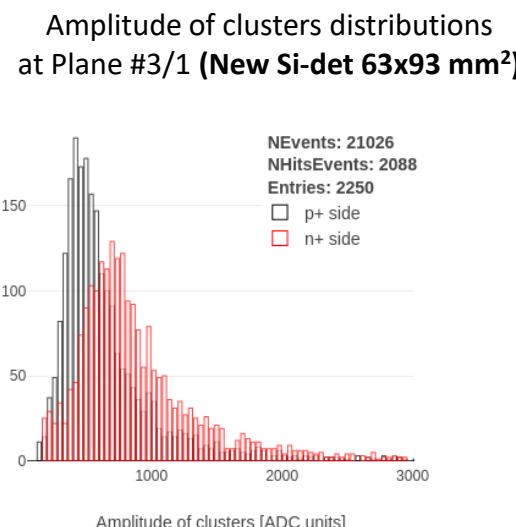
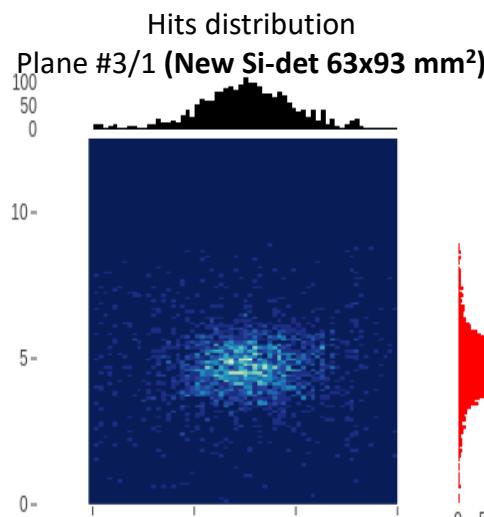
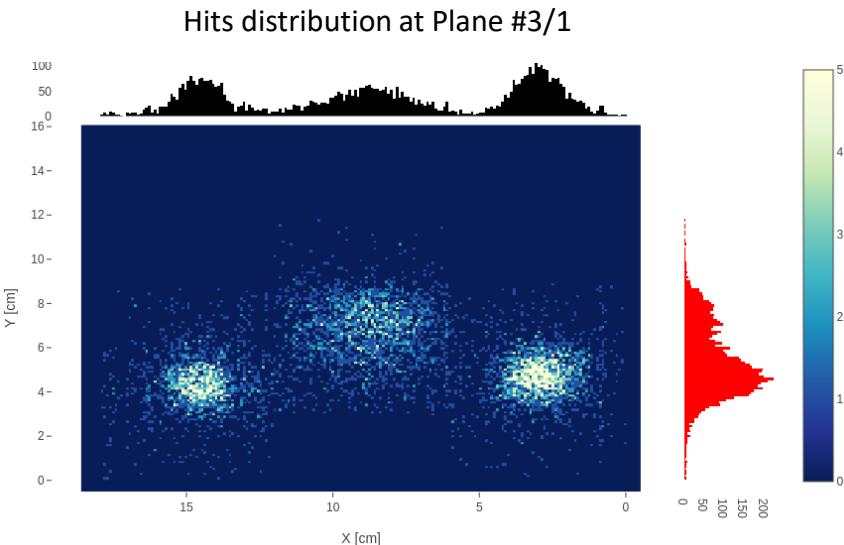
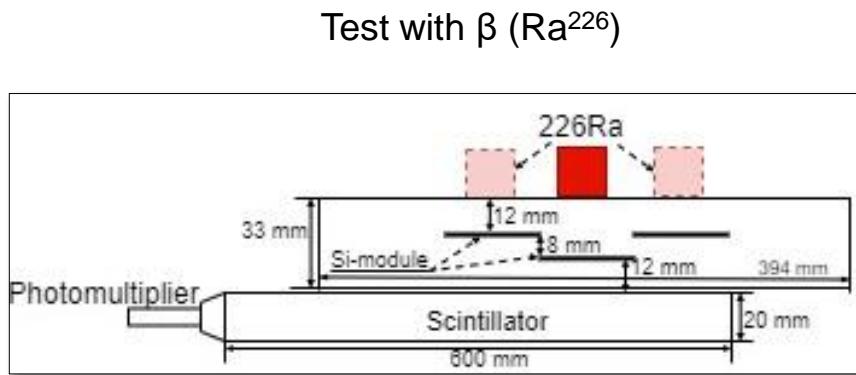
Al foil ( $20 \mu\text{m}$ ) + foam wall as a mechanical support (AIREX C 70.75, 3mm thickness, Density  $80 \text{ kg/m}^3$ ).  
Per unit area (one wall of shielding):  $0.010 \text{ g/cm}^2$  (Al) +  $0.024 \text{ g/cm}^2$  (foam)



## View Si-trigger multiplicity and Si-FW tracker

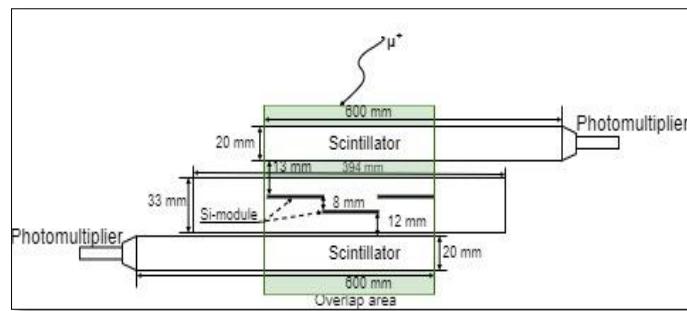


# Silicon Modules development on the new Si – detectors/2020 (63x93 mm<sup>2</sup>) Plane #3/1

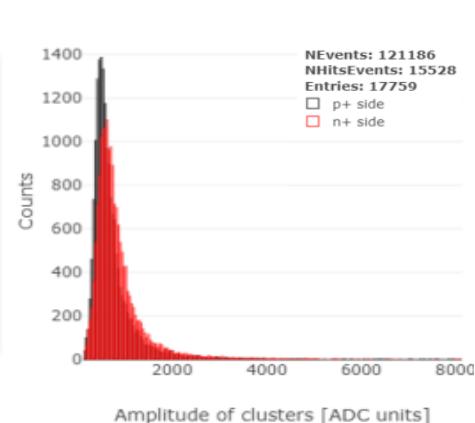


# Silicon Modules development on the new Si – detectors/2020 (63x93 mm<sup>2</sup>) Plane #3/1

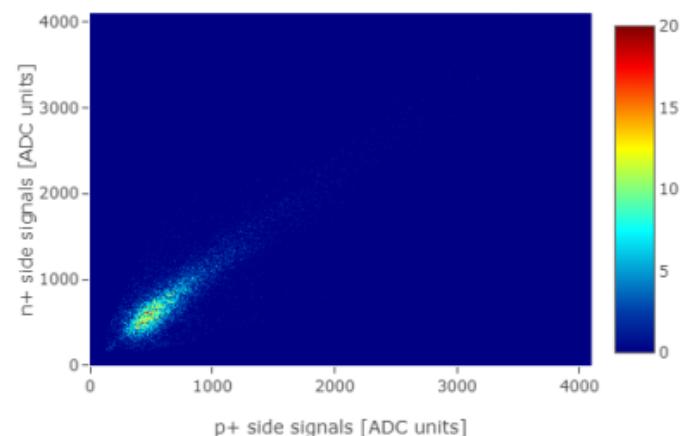
Cosmic test



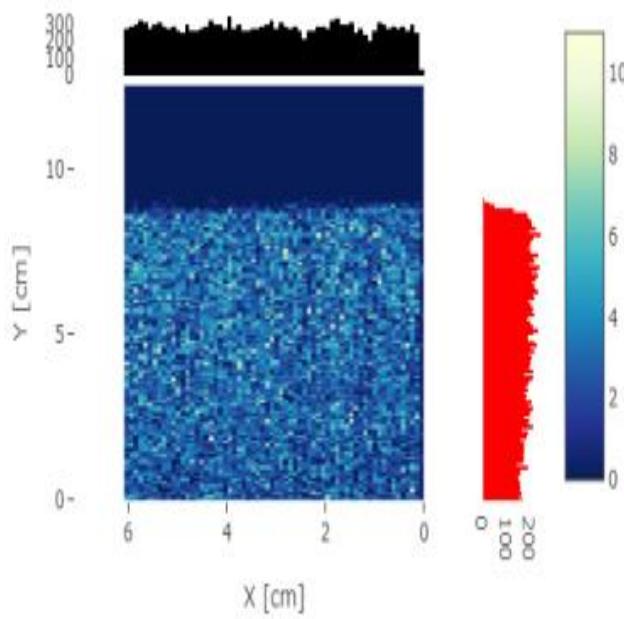
Amplitude of clusters distributions  
at Plane #3/1 (New Si-det 63x93 mm<sup>2</sup>)



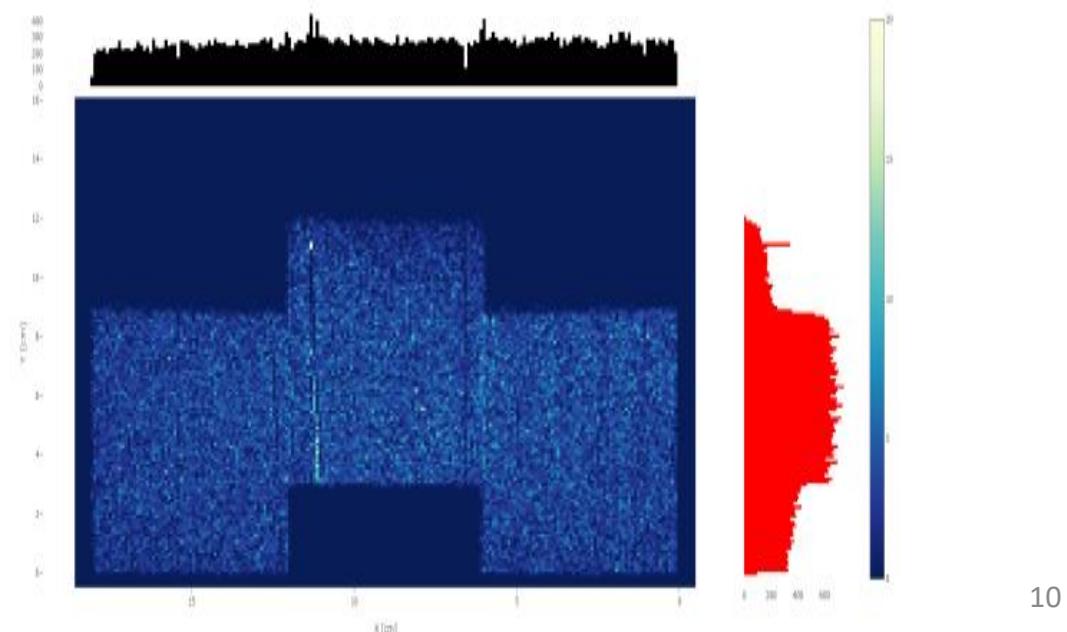
Correlation plot  
at Plane #3/1 (New Si-det 63x93 mm<sup>2</sup>)



Hits distribution  
Plane #3/1 (New Si-det 63x93 mm<sup>2</sup>)

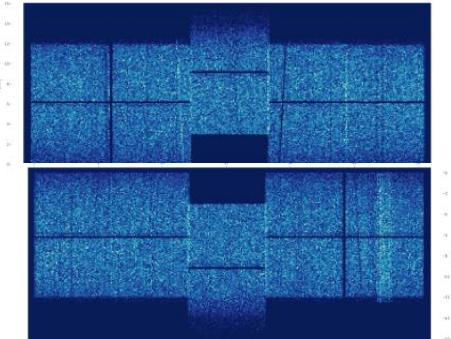


Hits distribution at Station #3/1

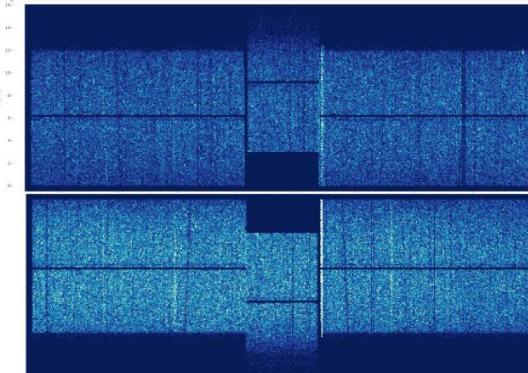


# Cosmic test of Silicon Planes

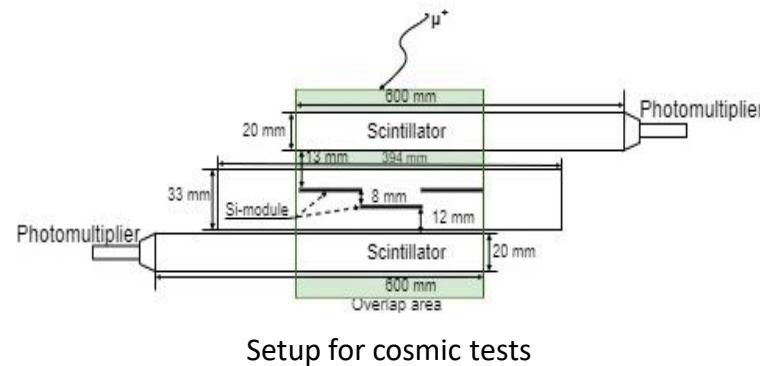
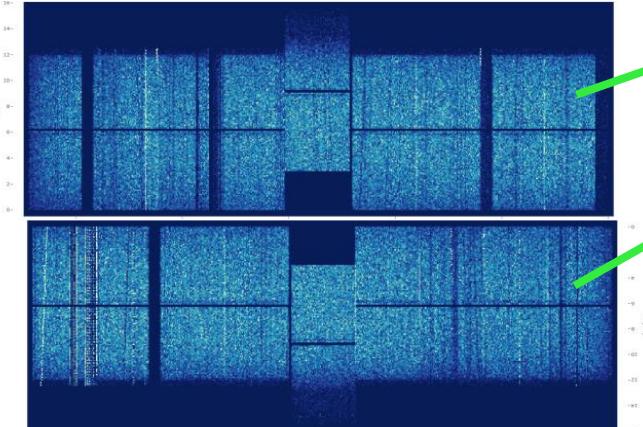
**2x5 modules**



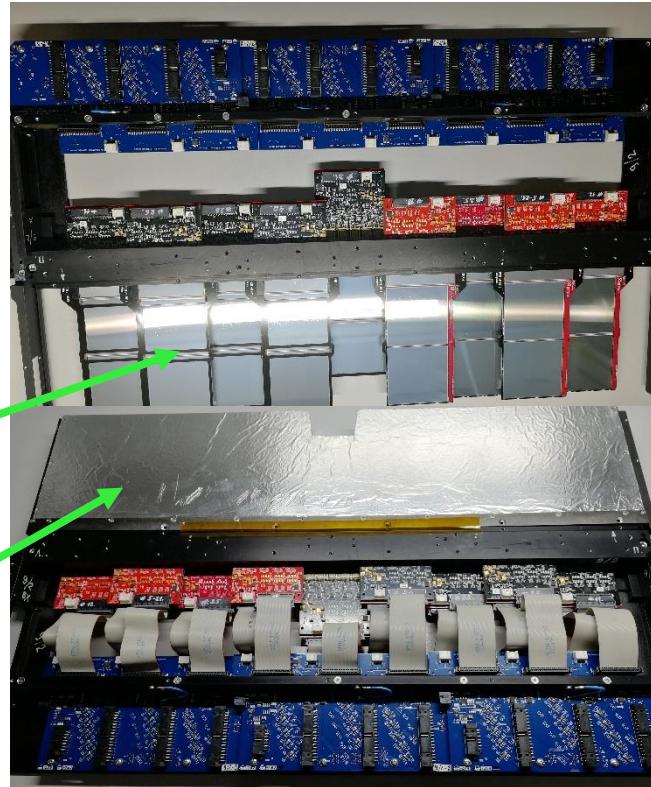
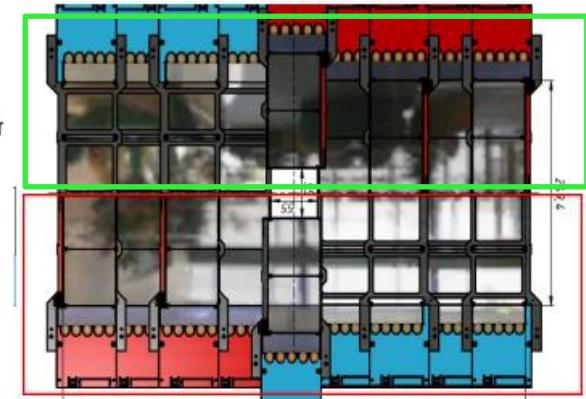
**2x7 modules**



**Si-plane (2x9) modules**

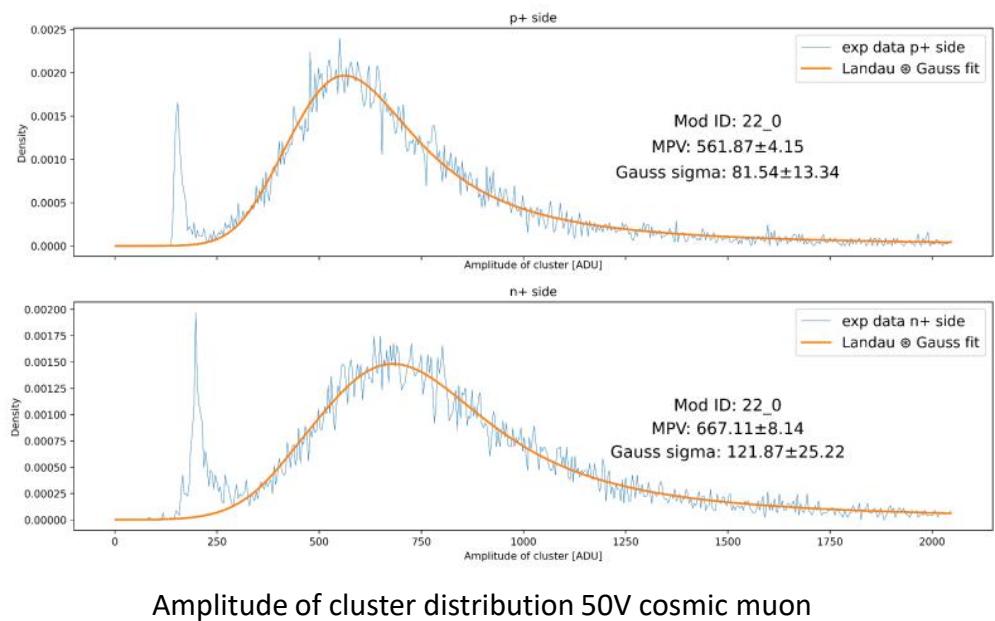
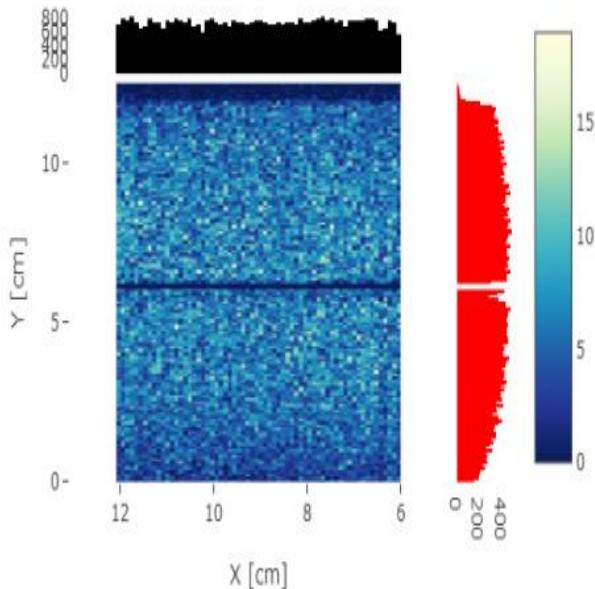


Setup for cosmic tests

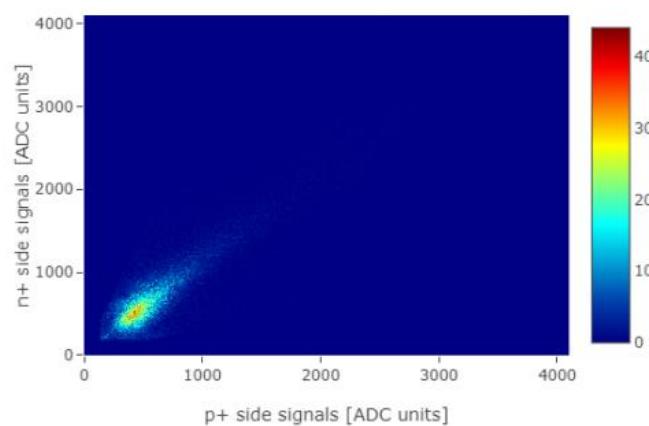
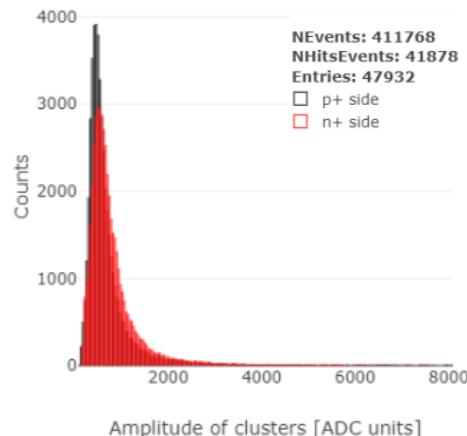


# Silicon Modules Plane #9/1 (cosmic test)

Hits distribution  
at Plane #9/1 module #1



Correlation plotat Plane #9/1



## Summary:

- Все кремниевые пучковые детекторы (2 профилометра + 3 пучковых трекера) смонтированы на ионопроводе BM&N и готовы для проведения тестов (измерение пьедесталов, шумов, темновых токов ( $I_d$ ), HV и LV = ON/OFF);
- Все четыре плоскости (60 000 каналов) передней части вершинного детектора смонтированы на ионопроводе BM&N и готовы для проведения тестов (измерение пьедесталов, шумов, темновых токов ( $I_d$ ), HV и LV = ON/OFF, температура охлаждения, slow control);
- Передняя Si – часть триггера множественности находится в стадии тестирования с  $\beta$  – источником на стенде, готовность к монтажу на канале BM&N к 01.10.2022.